

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al.                      Art Unit : Unknown  
 Serial No. : New Application                              Examiner : Unknown  
 Filed : December 9, 2003  
 Title : SEMICONDUCTOR CHIP AND METHOD FOR MANUFACTURING THE SAME

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT**

Applicants submit the references listed on the attached form PTO-1449.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

Desig. ID	Source
AL	<u>Japan 06-244360</u> : English Abstract – File 352:Derwent WPI, Accession No. 010052461 (2003)
AM	<u>Japan 08-186156</u> : English Abstract – File 352:Derwent WPI, Accession No. 010884478 (2003)
AN	<u>Japan 10-125929</u> : English Abstract – File 345:Inpadoc/Fam. & Legal Stat, Accession No. 14710078 (2003) and family to US Patent No. 6,372,608 (Desig. ID “AF”), US Publication No. 2002/0146893 (Desig. ID “AI”), and EP 0 858 110 (Desig. ID “AP”)
AO	<u>Japan 2000-294723</u> : English Abstract – File 345:Inpadoc/Fam. & Legal Stat, Accession No. 16514423 (2003)

This statement is being filed with the application. Accordingly, only copies of foreign patent documents and non-patent literature are enclosed. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: December 9, 2003

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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12732-185001	Application No. New Application
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Shunpei Yamazaki et al.	
		Filing Date December 9, 2003	Group Art Unit Unknown

### U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,834,327	11/10/1998	Yamazaki et al.			03/18/1996
	AB	6,127,199	10/03/2000	Inoue et al.			07/10/1998
	AC	6,133,626	10/17/2000	Hawke et al.			09/24/1998
	AD	6,258,623	07/10/2001	Moden et al.			07/08/1999
	AE	6,265,772	07/24/2001	Yoshida			06/15/1999
	AF	6,372,608	04/16/2002	Shimoda et al.			04/24/1998
	AG	6,423,614	07/23/2002	Doyle			06/30/1998
	AH	US 2002/0030189 A1	03/14/2002	Ishikawa			09/14/2001
	AI	US 2002/0146893 A1	10/10/2002	Shimoda et al.			03/07/2002
	AJ						
	AK						

### Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	06-244360	09/02/1994	JAPAN			ABS	
	AM	08-186156	07/16/1996	JAPAN			ABS	
	AN	10-125929	05/15/1998	JAPAN			ABS	
	AO	2000-294723	10/20/2000	JAPAN			ABS	
	AP	EP 0 858 110 A1	08/12/1998	EUROPE			In English	

### Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	Itsuo Watanabe et al.; "Anisotropic Conductive Films for Flat Panel Displays"; <i>IDW</i> '96; pp. 369-372; 1996
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	